



28'23

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Conf. No. 4380

K. Hashimoto et al.

Group Art Unit: 2823

Application No.: 10/028,429

Examiner: K. Nguyen

Filed: December 28, 2001

Docket No.: 107317-00039

For: DRY ETCHING WITH REDUCED DAMAGE TO MOS DEVICE

**AMENDMENT UNDER 37 C.F.R. § 1.121**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 11, 2004

Sir:

**INTRODUCTORY COMMENTS**

This paper is filed in response to the Office Action mailed February 12, 2004.  
Please consider the following.